



Attorney Docket SEL 147-CON

#17/ [Handwritten notes]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of )  
Hisashi OHTANI )  
Serial No.: 09/916,913 )  
Filed: July 27, 2001 )  
For: Method Of Manufacturing )  
Thin Film Transistor )  
Art Unit: 2825 )  
Examiner: L. Malsawma )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents ,  
P.O. Box 1450, Alexandria, VA 22313-1450 on

October 27, 2003

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

Signature

10/27/03

Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE E (AFTER FINAL)

Sir:

Applicant has the following response to the Final Rejection of June 27, 2003, a one month extension of time being separately herewith.

RECEIVED  
NOV - 4 2003  
TECHNOLOGY CENTER 2800

OK TO ENTER ARGUMENTS  
MMS